

Attorney Docket No. 061063-0311751  
Client Reference: OSP-16220

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: TAKASHI SHIBAYAMA, YOSHIO MURAKAMI and TAKAYUKI SHINGYOJI

Application No.:  
Filed: September 3, 2004

Confirmation No:  
Group No.:  
Examiner

For: PROCESS FOR PRODUCING SILICON SINGLE CRYSTAL LAYER AND SILICON SINGLE CRYSTAL LAYER

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**APPLICATION DATA SHEET**  
**37 C.F.R. § 1.76**

**BIBLIOGRAPHIC DATA**

**1. Applicant information**

First applicant: TAKASHI SHIBAYAMA  
Citizenship: JAPAN  
Residence: Kishima-gun, JAPAN

Second applicant: YOSHIO MURAKAMI  
Citizenship: JAPAN  
Residence: Saitama-shi, JAPAN

Third applicant: TAKAYUKI SHINGYOJI  
Citizenship: JAPAN  
Residence: Saitama-shi, JAPAN

**2. Correspondence information**

Correspondence for this application should be addressed as follows:

Customer No.: 00909

**3. Application information**

Title of Invention: PROCESS FOR PRODUCING SILICON SINGLE CRYSTAL LAYER AND SILICON SINGLE CRYSTAL LAYER

Docket number assigned to this application: 061063-0311751  
Suggested Classification: Class:

Subclass:  
Technology Center to which subject matter is assigned:

Total number of drawing sheets: 8  
Type of application: Utility  
Application is to be published. Suggested drawing figure for publication: 1

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

**4. Representative information**

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

**5. Domestic Priority information**

Domestic priority for this application is claimed as follows:

35 U.S.C. § 365(c):  
Application No.: PCT/JP03/02568  
Filed: March 5, 2003  
Status: Pending  
Relationship: Parent

**6. Foreign priority information**

Foreign priority is claimed for this application as follows:

Country: JAPAN  
Application No.: 2002-059182  
Filing Date: March 5, 2002  
Status: Pending

Country: JAPAN  
Application No.: 2002-261286  
Filing Date: September 6, 2002  
Status: Pending

**7. Assignee information**


The assignee(s) of this application is/are:

Sumitomo Mitsubishi Silicon Corporation  
2-1, Shibaura 1-chome, Minato-ku  
Tokyo,  
JAPAN

Extent of interest of assignee in application: 100%

Date: September 3, 2004

PILLSBURY WINTHROP LLP  
P.O. Box 10500  
McLean, VA 22102  
Customer No. 00909

  
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Signature of Practitioner  
John P. Darling  
Registration No. 44482  
(703) 905-2045